半导体物理

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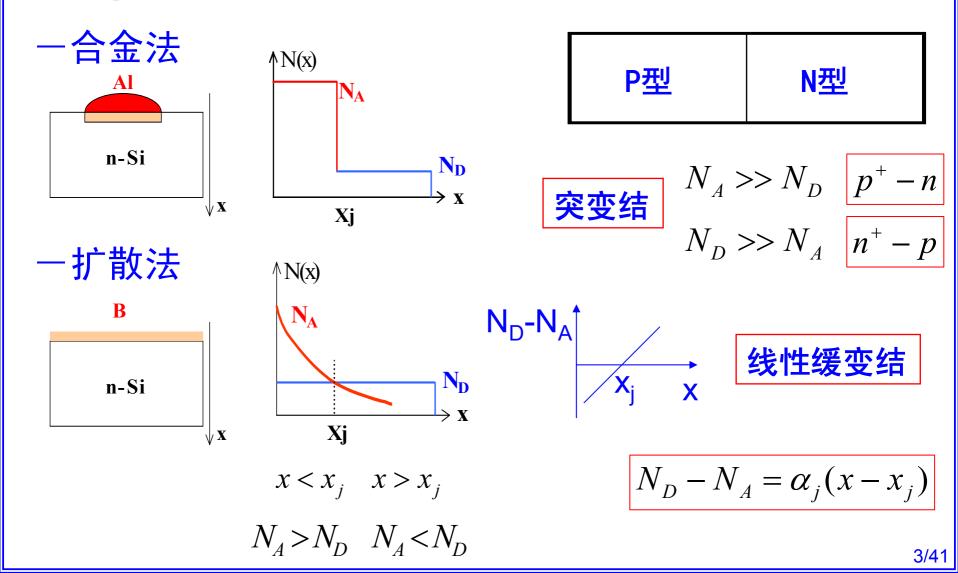
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http://10.14.3.121

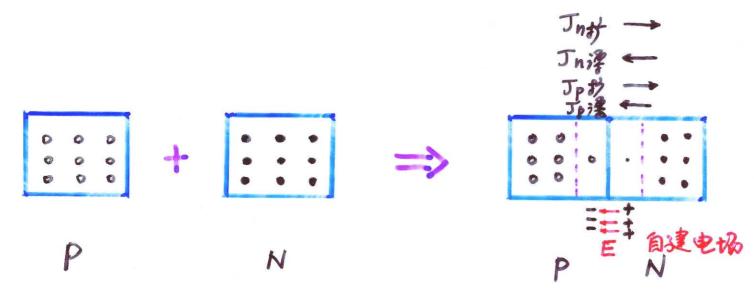
第八章 p-n结

- 8.1 平衡p-n结特性
- 8.2 p-n结电流电压特性
- 8.3 p-n结电容
- 8.4 p-n结的击穿
- 8.5 p-n结隧道效应

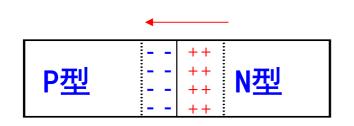
8.1.1 p-n结的形成及杂质分布



8.1.2 空间电荷区



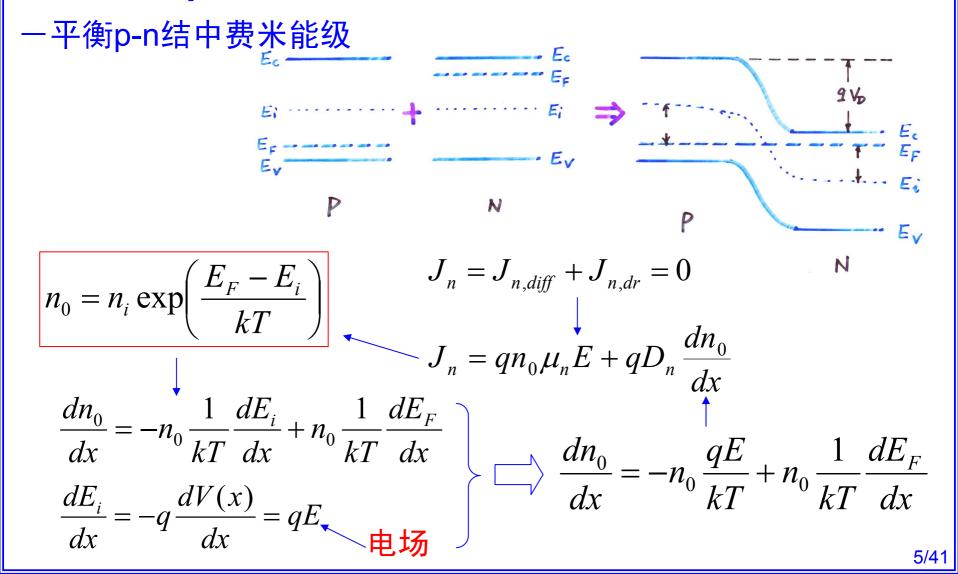
载流子浓度梯度 \rightarrow 扩散 \rightarrow 破坏电中性 \rightarrow 自建电场 \rightarrow 漂移电流 \rightarrow 动态平衡 \rightarrow 零净电流



$$J_n = J_{n,diff} + J_{n,dr} = 0$$

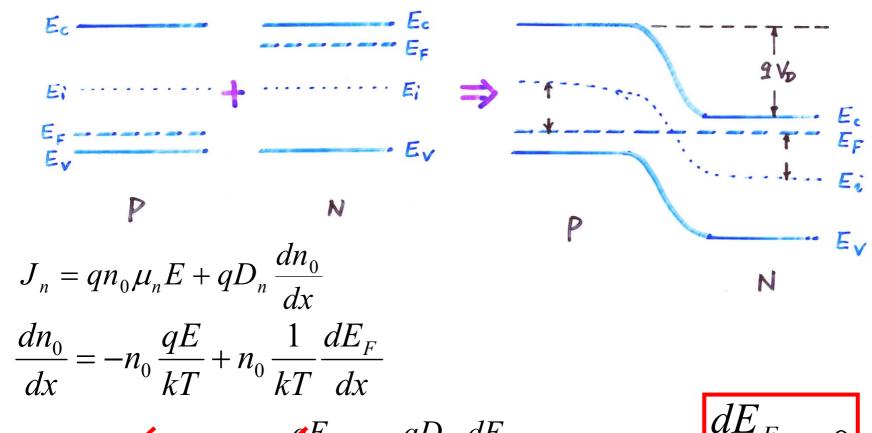
$$J_p = J_{p,diff} + J_{p,dr} = 0$$

8.1.3 平衡p-n结能带图



8.1.3 平衡p-n结能带图

一平衡p-n结中费米能级



$$J_n = q n_0 n_0 E - q D_n n_0 \frac{qE}{kT} + n_0 \frac{qD_n}{kT} \frac{dE_F}{dx} = 0 \qquad \frac{dE_F}{dx} = 0$$

8.1.4 p-n结接触电势差

$$qV_D = E_{F(n)} - E_{F(p)}$$

$$E_{F(n)} = E_i + kT \ln(N_D/n_i)$$

$$E_{F(p)} = E_i - kT \ln(N_A/n_i)$$

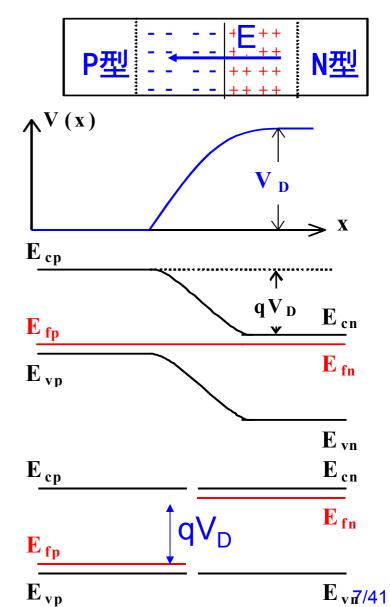
$$V_D = \frac{kT}{q} \ln \left(\frac{N_A N_D}{n_i^2} \right)$$

Si

Ge

例子:
$$N_A = 10^{17} \text{ cm}^{-3}$$
, $N_D = 10^{15} \text{ cm}^{-3}$





8.1.5 p-n结的载流子分布

$$n(x) = N_C \exp\left(-\frac{E_C(x) - E_f}{kT}\right) + E_{cn} - E_{cn}$$

$$m(x) = n_{n0} \exp\left(-\frac{E_c(x) - E_{cn}}{kT}\right) + E_c(x) - E_{cn} = qV_D - qV(x) E_{vp}$$

$$(E_c(x) - E_{cn}) + (E_c(x) - E_{cn}) + (E$$

$$n(-x_p) = n_{n0} \exp\left(-\frac{E_{cp} - E_{cn}}{kT}\right) = n_{n0} \exp\left(-\frac{qV_D}{kT}\right) = n_{p0}$$

$$n(x) = n_{p0} \exp\left[\frac{qV(x)}{kT}\right]$$

$$E_{Vp} - E_V(x) = qV(x)$$

$$p(x) = N_V \exp\left(-\frac{E_f - E_V(x)}{kT}\right) = p_{p0} \exp\left(-\frac{E_{Vp} - E_V(x)}{kT}\right)$$

$$n(x) = n_{p0} \exp\left[\frac{qV(x)}{kT}\right]$$

$$p(x) = N_{v} \exp\left(-\frac{E_{r} - E_{v}(x)}{kT}\right) = p_{p0} \exp\left(-\frac{E_{vp} - E_{v}(x)}{kT}\right)$$

$$p(x) = p_{p0} \exp\left(-\frac{E_{vp} - E_{v}(x)}{kT}\right) = p_{p0} \exp\left(-\frac{qV_{D}}{kT}\right) = p_{n0}$$

$$p(x) = p_{p0} \exp\left(-\frac{qV(x)}{kT}\right) = p_{n0} \exp\left(-\frac{qV_{D}}{kT}\right) = p_{n0}$$

$$p(x) = p_{p0} \exp\left(-\frac{qV(x)}{kT}\right) = p_{n0} \exp\left(-\frac{qV_{D}}{kT}\right) = p_{n0}$$

 $\mathbf{E}_{\mathbf{fn}}$

8.1.5 p-n结的载流子分布

一势垒区中的载流子浓度估算

$$n(x) = n_{p0} \exp\left[\frac{qV(x)}{kT}\right] = n_{n0} \exp\left[\frac{qV(x) - qV_D}{kT}\right]$$

$$p(x) = p_{p0} \exp \left[-\frac{qV(x)}{kT} \right]$$
 若位置x满足 $E_c(x) = E_{cn} + 0.1eV$ —

$$V(\mathbf{r}) - V = 0.1eV$$

$$V(x) = V_D - 0.1eV$$

$$T = 300K$$

$$\frac{V_D = 0.7eV}{n(x) = n_{n0} \exp\left[-\frac{0.1}{0.026}\right]} \approx \frac{N_D}{50} \quad p(x) = p_{p0} \exp\left[-\frac{0.6}{0.026}\right] \approx 10^{-10} N_A$$

$$\stackrel{\text{EFR}}{=} = 16.00 \quad \text{As in this is } = 3.5c \text{ in this } = 3.$$

耗尽层近似:势垒区中载流子浓度可以忽略, 空间电荷密度就等于电离杂质浓度

